

L Numb r	Hits	Search Text	DB	Time stamp
-	7119	thin with film with filter	USPAT; EPO; JPO; DERWENT	2003/03/25 11:09
-	23626	indium with tin with oxide	USPAT; EPO; JPO; DERWENT	2003/03/25 11:13
-	7365	WDM	USPAT; EPO; JPO; DERWENT	2003/03/25 11:12
-	3	(thin with film with filter) and (indium with tin with oxide) and WDM	USPAT; EPO; JPO; DERWENT	2003/03/25 13:13
-	3298	(indium with tin with oxide) with (compris\$3 or composition)	USPAT; EPO; JPO; DERWENT	2003/03/25 11:16
-	6	((indium with tin with oxide) with (compris\$3 or composition)) and WDM	USPAT; US-PGPUB; DERWENT	2003/03/25 11:14
-	4	((((indium with tin with oxide) with (compris\$3 or composition)) and WDM) not ((thin with film with filter) and (indium with tin with oxide) and WDM)	USPAT; US-PGPUB; DERWENT	2003/03/25 11:15
-	124	(indium with tin with oxide) with ((compris\$3 or composition) and "%")	USPAT; EPO; JPO; DERWENT	2003/03/25 11:19
-	84	(indium with tin with oxide) with ((compris\$3 or composition) and percent)	USPAT; EPO; JPO; DERWENT	2003/03/25 11:18
-	0	(indium with tin with oxide) with ((compris\$3 or composition) and ((tin or indium) near 3percent))	USPAT; EPO; JPO; DERWENT	2003/03/25 11:19
-	55	(indium with tin with oxide) with ((compris\$3 or composition) and ((tin or indium) near 3 "%"))	USPAT; EPO; JPO; DERWENT	2003/03/25 11:19
-	5576	wavelength with division with multiplexing	USPAT; EPO; JPO; DERWENT	2003/03/25 13:49
-	3	(thin with film with filter) and (indium with tin with oxide) and (wavelength with division with multiplexing)	USPAT; EPO; JPO; DERWENT	2003/03/25 13:15
-	579015	cavit\$3	USPAT; EPO; JPO; DERWENT	2003/03/25 13:15
-	173	(wavelength with division with multiplexing) same cavit\$3	USPAT; EPO; JPO; DERWENT	2003/03/25 13:15
-	0	((wavelength with division with multiplexing) same cavit\$3) and (thin with film with filter) and (indium with tin with oxide)	USPAT; EPO; JPO; DERWENT	2003/03/25 13:15

-	7	((wavelength with division with multiplexing) same cavity) and (indium with tin with oxide)	USPAT; EPO; JPO; DERWENT	2003/03/25 13:33
-	2	6215592.pn.	USPAT; EPO; JPO; DERWENT	2003/03/25 13:33
-	260647	(silicon or aluminum) with oxide	USPAT; EPO; JPO; DERWENT	2003/03/25 13:50
-	19	(indium with tin with oxide) and (wavelength with division with multiplexing) and ((silicon or aluminum) with oxide)	USPAT; EPO; JPO; DERWENT	2003/03/25 13:50